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Message

DOCKET No. : GS 152 Div

Please see attached: Amendment

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PATENT APPLICATION
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Iuan Hshich et al.
Application No. 10/725,325
Filed: December 1, 2003
Title: Trench MOSFET Device with Improved On-Resistance
Art Unit: 2811
Examiner: Steven Loke
Docket No.: GS 152 Div

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated May 18, 2004, please consider the following amendment(s) and response: